

**10/594635**

New PCT National Phase Application

Docket No. 2691-000050/US

**IAP5 Rec'd PCT/PTO 28 SEP 2006**

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant(s): Yoshiharu OHTA et al.

Int'l App. No.: PCT/JP2005/005766

Application No.: **NEW APPLICATION**

Filed: September 28, 2006

For: SEMICONDUCTOR POLISHING COMPOSITION  
(as amended)

**PRELIMINARY AMENDMENT**

Customer Service Window  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

September 28, 2006

**Mail Stop PCT**

Sir:

The following preliminary amendments and remarks are respectfully submitted in connection with the above-identified application. Prior to examination of the present application, please consider the following:

**Amendments to the Title** begin on page 2 of this Preliminary Amendment.

**Amendments to the Abstract** begin on page 3 of this Preliminary Amendment.

**Amendments to the Specification** begin on page 4 of this Preliminary Amendment.

**Amendments to the Claims** begin on page 5 of this Preliminary Amendment.

	Claims remaining after Amendment		Highest number previously paid for		Present extra
Total	12	-	20	=	0
Independent	1	-	3	=	0